



1746

PATENT  
Attorney Docket No. AMAT/4215/CMP/CMP/RKK

**CERTIFICATE OF MAIL (37 CFR 1.8(a))**

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, DC 20231 on November 27, 2002.

Signed: [Signature]  
Debbie Nishihara

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:  
Sun et al.

Serial No. 09/645,690 ✓

Filed: August 24, 2000 ✓

For: Cu CMP POLISHING PAD  
CLEANING ✓

Art Unit: 1746

Examiner: Gentle E. Winter

Attorney Docket No.  
AMAT/4215/CMP/CMP/RKK

**TRANSMITTAL**

Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:


Please find enclosed the following documents relating to the subject patent application:

- [X] Response to Office Action dated August 27, 2002
- [X] Executed Associate Power of Attorney
- [X] Return Postcards

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The Commissioner is authorized to charge any additional fees including any extension of time fees to Deposit Account No. 20-0782 (Order No. AMAT/4215).

Respectfully submitted,

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